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(54) Title: ELECTRONICALLY TUNABLE, LOW-LOSS CERAMIC MATERIALS INCLUDING A TUNABLE DIELECTRIC PHASE AND MULTIPLE METAL OXIDE PHASES

(57) Abstract: Electronically tunable dielectric materials having favorable properties are disclosed. The electronically tunable materials include an electronically tunable dielectric phase such as barium strontium titanate in combination with at least two additional metal oxide phases. The additional metal oxide phases may include, for example, oxides of Mg, Si, Ca, Zr, Ti and Al. The electronically tunable materials may be provided in bulk, thin film and thick film forms for use in devices such as phased array antennas, tunable filters and the like. The materials are useful in many applications, including the area of radio frequency engineering and design.

ELECTRONICALLY TUNABLE, LOW-LOSS CERAMIC MATERIALS INCLUDING A TUNABLE DIELECTRIC PHASE AND MULTIPLE METAL OXIDE PHASES

FIELD OF THE INVENTION

5 The present invention relates to electronically tunable ceramic materials which have favorable properties for many applications, including the area of radio frequency (RF) engineering and design. More particularly, the present invention relates to electronically tunable ceramic materials comprising a tunable dielectric phase such as barium strontium titanate (BSTO) in combination with multiple metal oxide phases.

BACKGROUND INFORMATION

10 Microwave devices such as electronically scanning antennas, phased array antennas, electronic down tilt antennas, electronically tunable filters, electronically tunable radar and tunable oscillators have been proposed for use, but their high costs have prevented widespread commercial implementation. The existence of low cost tuning technology would revolutionize the industry of microwave components and antennas.

15 Tuning refers to the ability to change the dielectric constant of a material. This translates in the microwave component field as the ability to use the same component and change the frequency of operation by changing the input voltage or current. It can allow for a single filter to frequency-hop during operation. For antennas, being able to tune using
20 low cost technology would create a new class of phased array antennas, which could be used in common households instead of being limited to large, expensive systems. Phased array antennas can be described as electronically scanning antennas. By using electronically scanning antennas, satellite communications can be available in many situations, because the antennas would allow for tracking of a satellite. This means voice and data communications
25 can be done in a mobile arena. Also, mobile communications would be available at a global level without the need for major infrastructure.

30 A phased array refers to an antenna configuration composed of a large number of elements that emit phased signals to form a radio beam. The radio signal can be electronically steered by the active manipulation of the relative phasing of the individual antenna elements. This electronic beam steering concept applies to both the transmitter and the receiver. Phased array antennas are advantageous in comparison to their mechanical counterparts with respect to their speed, accuracy and reliability. The replacement of gimbal

mounted mechanical antennas by phased array antennas increases survivability through more rapid and accurate target identification. For example, complex tracking exercises can be performed rapidly and accurately with a phased array antenna system.

Future communications will also require wideband communications using frequency-hopping techniques, so that large amounts of digital data can be transferred over the band. A critical component for these applications is a low cost, fast acting tunable filter. Digital data could be distributed or encoded over a band of frequencies in a sequence determined by control circuitry of the tunable filter. This would allow for several users to transmit and receive over a common range of frequencies.

Technologies for scanning that could possibly be adapted for phase shifter applications are ferrite phase shifters and semiconductor diode phase shifters. Although ferrites are currently the most widely used type of phase shifter materials, they are mostly limited to military applications. The major reason for this is that they are very expensive to manufacture. Secondary reasons include the fact that they are not designed to work in a broadband situation. When the frequency changes, a new set of materials has to be designed and manufactured. They are also very bulky in size and heavy. Furthermore, such phase shifters are difficult or impossible to make in a planar configuration. Conventional ferrites are also driven by high power due to the fact that they activate based on current.

Conventional diode phase shifters are also high cost because they require active electronic circuits to be added to designs in order to compensate for their high loss at microwave frequencies. They do not have good power handling characteristics. When power is put through the diodes, they start to behave in a very non-linear fashion, or they break down. Diodes also require holding power in order to maintain accuracy, as well as power during switching.

Barium titanate is one of the known ceramics tunable at room temperature. Another known tunable ceramic is strontium titanate. However, this material by itself must be super cooled in order to have usable tuning characteristics. Other tunable dielectrics include lead zirconium titanates (PZT), lead lanthanum zirconium titanates (PLZT), PbTiO_3 , KNbO_3 , LaTaO_3 , BaCaZrTiO_3 , NaNO_3 and other ferroelectric perovskites. The problem with these known ferroelectrics is that their losses are very high at room temperature. This makes these materials essentially useless at microwave frequencies. One way to combat this problem is by means of producing a low loss but still tunable composite material with reasonable dielectric constants.

Barium strontium titanate (BSTO) has been used for its high dielectric constant, on the order of 200 to 6,000, and its large change in dielectric constant with applied voltage, on the order of 25 to 75 percent at a field of 2V/micron. Some prior art ferroelectric composite materials which include BSTO are disclosed in U.S. Patent No. 5,427,988 to Sengupta et al. entitled "Ceramic Ferroelectric Composite Material BSTO-MgO"; U.S. Patent No. 5,645,434 to Sengupta et al. entitled "Ceramic Ferroelectric Composite Material BSTO-Magnesium Based Compound"; U.S. Patent No. 6,074,971 to Chiu et al. entitled "Ceramic Ferroelectric Composite Materials with Enhanced Electronic Properties BSTO-Mg Based Compound - Rare Earth Oxide"; and U.S. Patent Application Serial No. 09/594,837 to Chiu et al. filed June 15, 2000 entitled "Electronically Tunable Ceramic Materials Including Tunable Dielectric and Metal Silicate Phases", each of which is incorporated herein by reference.

The idea of a voltage tunable dielectric has been proposed for use in antenna applications in a paper entitled "Planar Microwave Electro-Optic Phase Shifters", *Microwave Journal*, Volume 35 (6), June 1992. There is a need for new materials which have desirable electronic properties in order to make this possible. As with most ferroelectrics which are tunable at room temperature, the losses at frequencies above 600MHz become too high to use cost effectively. Also, high dielectric constants makes it virtually impossible to integrate and match them to RF circuits. This causes increased insertion losses.

The present invention has been developed in view of the foregoing, and to address other deficiencies of the prior art.

SUMMARY OF THE INVENTION

The present invention provides electronically tunable ceramic materials. The materials comprise at least one tunable dielectric phase selected from barium titanate, strontium titanate, barium strontium titanate, lead titanate, lead zirconium titanate, lead lanthanum zirconium titanate, potassium niobium oxide, lanthanum tantalum oxide, barium calcium zirconium titanate, sodium nitrate and other electronically tunable ferroelectrics. A preferred tunable dielectric phase comprises barium strontium titanate of the formula $Ba_xSr_{1-x}TiO_3$. In the formula $Ba_xSr_{1-x}TiO_3$, x can be a value from 0 to 1, preferably from about 0.15 to about 0.6.

The present electronically tunable ceramic materials also include multiple metal oxide phases in an amount up to about 80 weight percent of the material. The

additional metal oxide phases are used to control the microwave properties, e.g., by reducing the loss tangents and dielectric constants, while maintaining tunability and improving temperature stability. The additional metal oxide phases provide substantially improved characteristics, for example, substantially increased tuning while exhibiting low insertion losses, making the materials useful as tunable dielectrics for microwave applications. The materials also exhibit improved temperature stability, biasing and response time in comparison with conventional materials. Also, the additional metal oxide materials allow the dielectric constant of the tunable dielectric phase, e.g., BSTO, to be adjusted to the desired levels while maintaining tunability. The significant improvements in tunability, stability and adjustability of dielectric constant without degradation of electric loss enable new RF/microwave applications.

The materials are highly advantageous for microwave component designs because their tuning characteristics allow for the construction of devices having variable properties. Such variable properties allow for new designs, e.g., for filters which can vary the frequency of operation and allow for frequency-hopping of microwave devices, and for antennas to scan and track satellites electronically, as well as many other applications. The electronic properties of the present materials can be adjusted or tailored for a specific microwave application or design. Tunable materials with very low loss insertion are provided. In addition, the materials can be readily used in a wide range of frequencies, e.g., from 100kHz to 60GHz. Since the preferred materials require voltage changes in order to switch, very low current and power requirements are achieved. The materials may be provided in many different manufacturable forms such as bulk ceramics, thick films, and thin films.

An aspect of the present invention is to provide an electronically tunable dielectric material including at least one tunable dielectric phase and at least two additional metal oxide phases.

Another aspect of the present invention is to provide a method of forming an electronically tunable dielectric material. The method includes the steps of mixing particles of at least one tunable dielectric material and particles of at least two additional metal oxides, followed by sintering.

These and other aspects of the present invention will be more apparent from the following description.

DETAILED DESCRIPTION

The present electronically tunable ceramic compositions comprise at least one electronically tunable dielectric phase, such as barium strontium titanate, in combination with at least two additional metal oxide phases. Barium strontium titanate of the formula $Ba_xSr_{1-x}TiO_3$ is a preferred electronically tunable dielectric material due to its favorable tuning characteristics, low curie temperatures and low microwave loss properties. In the formula $Ba_xSr_{1-x}TiO_3$, x can be any value from 0 to 1, preferably from about 0.15 to about 0.6. More preferably, x is from 0.3 to 0.6.

Other electronically tunable dielectric materials may be used partially or entirely in place of barium strontium titanate. An example is $Ba_xCa_{1-x}TiO_3$, where x can vary from about 0.2 to about 0.8, preferably from about 0.4 to about 0.6. Additional electronically tunable ferroelectrics include $Pb_xZr_{1-x}TiO_3$ (PZT) where x ranges from about 0.05 to about 0.4, lead lanthanum zirconium titanate (PLZT), lead titanate ($PbTiO_3$), barium calcium zirconium titanate ($BaCaZrTiO_3$), sodium nitrate ($NaNO_3$), $KNbO_3$, $LiNbO_3$, $LiTaO_3$, $PbNb_2O_6$, $PbTa_2O_6$, $KSr(NbO_3)$ and $NaBa_2(NbO_3)5KH_2PO_4$.

In addition to the electronically tunable dielectric phase, the present electronically tunable materials include at least two additional metal oxide phases. The additional metal oxides may include metals from Group 2A of the Periodic Table, i.e., Mg, Ca, Sr, Ba, Be and Ra, preferably Mg, Ca, Sr and Ba. The additional metal oxides may also include metals from Group 1A, i.e., Li, Na, K, Rb, Cs and Fr, preferably Li, Na and K. Metals from other Groups of the Periodic Table may also be suitable constituents of the metal oxide phases. For example, refractory metals such as Ti, V, Cr, Mn, Zr, Nb, Mo, Hf, Ta and W may be used. Furthermore, metals such as Al, Si, Sn, Pb and Bi may be used. In addition, the metal oxide phases may comprise rare earth metals such as Sc, Y, La, Ce, Pr, Nd and the like.

The additional metal oxides may include, for example, zirconates, silicates, titanates, aluminates, stannates, niobates, tantalates and rare earth oxides. Preferred additional metal oxides include Mg_2SiO_4 , MgO , $CaTiO_3$, $MgZrSrTiO_6$, $MgTiO_3$, $MgAl_2O_4$, WO_3 , $SnTiO_4$, $ZrTiO_4$, $CaSiO_3$, $CaSnO_3$, $CaWO_4$, $CaZrO_3$, $MgTa_2O_6$, $MgZrO_3$, MnO_2 , PbO , Bi_2O_3 and La_2O_3 . Particularly preferred additional metal oxides include Mg_2SiO_4 , MgO , $CaTiO_3$, $MgZrSrTiO_6$, $MgTiO_3$, $MgAl_2O_4$, $MgTa_2O_6$ and $MgZrO_3$.

The additional metal oxide phases are typically present in total amounts of from about 1 to about 80 weight percent of the material, preferably from about 3 to about 65 weight percent, and more preferably from about 5 to about 60 weight percent. In a particularly preferred embodiment, the additional metal oxides comprise from about 10 to about 50 total weight percent of the material. The individual amount of each additional metal oxide may be adjusted to provide the desired properties. Where two additional metal oxides are used, their weight ratios may vary, for example, from about 1:100 to about 100:1, typically from about 1:10 to about 10:1 or from about 1:5 to about 5:1. Although metal oxides in total amounts of from 1 to 80 weight percent are typically used, smaller additive amounts of from 0.01 to 1 weight percent may be used for some applications.

In one embodiment, the additional metal oxide phases may include at least two Mg-containing compounds. In addition to the multiple Mg-containing compounds, the material may optionally include Mg-free compounds, for example, oxides of metals selected from Si, Ca, Zr, Ti, Al and/or rare earths. In another embodiment, the additional metal oxide phases may include a single Mg-containing compound and at least one Mg-free compound, for example, oxides of metals selected from Si, Ca, Zr, Ti, Al and/or rare earths.

As used herein, the term "electronically tunable dielectric material" means a material that exhibits a variable dielectric constant upon the application of a variable voltage. The term "voltage tunable dielectric material" as used herein means a material that exhibits a variable dielectric constant with a variable applied voltage. The tunability may be defined as the dielectric constant of the material with an applied voltage divided by the dielectric constant of the material with no applied voltage. Thus, the voltage tunability percentage may be defined by the formula:

$$T = ((X - Y) / X) \cdot 100;$$

where X is the dielectric constant with no voltage and Y is the dielectric constant with a specific applied voltage. High tunability is desirable for many applications. For example, in the case of waveguide-based devices, the higher tunability will allow for shorter electrical length, which means a lower insertion loss can be achieved in the overall device. Higher tunability will result in a large angle of sweep at lower operation voltages. The present voltage tunable dielectric materials preferably exhibit a tunability of at least about 20 percent at 8V/micron, more preferably at least about 25 percent at 8V/micron. For example, the voltage tunable dielectric material may exhibit a tunability of from about 30 to about 75

percent or higher at 8V/micron. The tunability of the present materials comprising multiple additional metal oxide phases has been found to be superior to binary composite materials.

In accordance with the present invention, the combination of tunable dielectric materials such as BSTO with additional metal oxides allows the materials to have high tunability, low insertion losses and tailorable dielectric properties, such that they can be used in microwave frequency applications. The materials demonstrate improved properties such as increased tuning, reduced loss tangents, reasonable dielectric constants for many microwave applications, stable voltage fatigue properties, higher breakdown levels than previous state of the art materials, and improved sintering characteristics. A particular advantage of the present materials is that tuning is dramatically increased compared with conventional low loss tunable dielectrics. The tunability and stability achieved with the present materials enables new RF applications not previously possible. A further advantage is that the materials may be used at room temperature. The electronically tunable materials may be provided in several manufacturable forms such as bulk ceramics, thick film dielectrics and thin film dielectrics.

The dielectric constants of the present materials preferably range from about 15 to 1,500, and may be tailored to a particular application. In many cases, a lower dielectric constant on the order of 100 is needed for ease of matching into the circuit. A lower dielectric constant is preferable for waveguides so that impedance matching is easier. In other cases, such as varactor based filters, a higher dielectric constant such as 300 to 400 may be needed to achieve the correct capacitance required for a specific frequency band. For some RF applications, such as delay lines, very high dielectric constants, e.g., 800 to 1,000, are needed to obtain the correct delay.

The loss tangent is a measure of the dissipation of microwave energy in a device and can be defined as $\tan \delta$. Lower loss tangents are usually desirable. Depending on the frequency of an application, usable loss tangents are usually below 0.04. If low loss tangent at high microwave frequencies can be achieved, cheaper devices may be provided because there is no need for active amplification of signals. The addition of the metal oxide phases in the present materials decreases the insertion loss substantially. Losses at 10GHz in many cases are below 0.02, and for some compositions the loss at 24GHz is below the 0.04 level.

In addition to these electronic properties, there are other advantages to the present compositions. The present materials exhibit better temperature stability compared

with binary composites. These materials also show a good resistance to breakdown even at high electrical field. For example, several of the present compositions have been held at 9V/micron for several days without breakdown.

Another advantage is that with the addition of multiple oxide phases, the tuning remains almost the same while the dielectric loss is decreased from that of the two-phase composite. In addition, the dielectric constant of the ternary composites can be adjusted without decreasing tuning and increasing dielectric loss, which enable new RF applications not previously possible.

In accordance with an embodiment of the present invention, at RF frequencies, the dielectric constant of $\text{Ba}_x\text{Sr}_{1-x}\text{TiO}_3$ can be decreased to usable values for microwave designs. The present materials also decrease the loss of the baseline BSTO materials such that these ceramics can now be considered for passive device designs at higher frequencies such as 600MHz and above. The tunability of these materials is also maintained from the baseline BSTO materials. Tuning characteristics for these materials is much better than that of the current state of the art.

The present materials may also exhibit a more linear increase in tuning compared with the current state of the art materials. These materials also show a good resistance to breakdown even at high voltages. For example, several different compositions have been held at 9V/micron for several days without exhibiting any changes. Also, cycling tests have shown that the tuning of these materials may fall within a +/-1% value for 1,000 cycles or more.

The present materials are also very robust because compositions produced from lower purity commercial grade materials have been found to possess electronic properties very similar to samples made from high purity materials. The production of these compositions using starting powders from several different manufacturers exhibit electronic properties within acceptable standard deviations. The present materials can also be processed in water, which saves cost and is more environmentally sound than solvent processing.

The present materials can be produced by conventional manufacturing processes. For example, powder forms of BaTiO_3 and SrTiO_3 may be mixed to form the desired stoichiometry of the electronically tunable dielectric phase. The powders may be ball-milled in either a liquid solvent or deionized water, or dry mixed with ceramic grinding media for approximately 24 hours. These powders are then allowed to dry. The mixed powder is then calcined at temperatures of from about 800°C to about 1,200°C to form

BSTO. The calcined powder may then undergo another mixing step with powders of the additional metal oxide phases in the desired ratios to form the composite. This mixing step may be performed in a liquid medium or dry. During mixing conventional binders may or may not be added. The tunable dielectric phase and the additional metal oxide phases preferably have an average particle size of from about 0.1 to about 5 micron, more preferably from about 1.5 to about 2.5 micron. After mixing, the composite powder is then dried and ground to a workable particle size. At this point the powder may be made into several different forms that can be characterized as bulk materials, thick films or thin films.

The composite powder made using the above specifications may be compacted to form a shape. This process can be performed by isostatic pressing, uniaxial pressing or the like. The green ceramic body is then fired at the appropriate temperature in order to densify the compact. Electrodes may be placed on the sintered ceramic via a hybrid or thin film method to the specifications of a desired design.

The composite powder may also be blended with a polymeric binder for tape casting. The tape casting slurry may be pumped into a tape caster with a doctor blade set for a desired thickness. As the caster moves a carrier sheet such as Mylar under the doctor blade, the slurry forms a film of the desired thickness. The film is allowed to dry and then it is cut and/or slit to the shape needed. This green body is then fired with the appropriate binder burn out schedule. The sintered part may undergo an annealing stage dependent upon the quality of the fired tape. The tapes can then be electroded in a manner similar to the bulk material.

Alternatively, the composite powder can be mixed with a polymeric binder for screen printing. The slurry may be gently blended and then placed in a 3-roll mill or attritor mill to thoroughly mix the slurry. The ceramic ink is then printed using a screen with the appropriate mesh and emulsion for the desired finished print thickness. The ceramic may be printed onto any suitable substrate, e.g., a ceramic substrate such as MgO. The films are then metallized with a pattern necessary for the desired device. For example, in the case of varactors, over one hundred varactors can be put on a single chip and diced out for placement into microwave devices.

The fabrication processes primarily described herein deal with the production of bulk materials and thick film slurries. However, other suitable processing methods include die casting, injection molding, uniaxial pressing, isostatic pressing, tape casting, roll compaction and the like.

Electronic properties of some of the materials of the present invention are shown in Tables 1-5. The properties achieved in accordance with the present invention are significant because the material maintains high tuning with low microwave losses with the addition of the multiple oxide phases. The dielectric constant of the composite is readily tailorable. The composite also has high breakdown voltages.

Table 1

Low and High Frequency Data of BSTO with varying Amounts Mg_2SiO_4 and MgO

BSTO/ Mg_2SiO_4 / MgO	Dielectric Constant (1MHz)	Dielectric Loss (1MHz)	Dielectric Constant (10GHz)	Dielectric Loss (10GHz)	Dielectric Constant (24GHz)	Dielectric Loss (24GHz)	Tunability (2V/ μm) (%)	Tunability (4V/ μm) (%)	Tunability (6V/ μm) (%)	Tunability (8V/ μm) (%)
35.1005	503.2	0.0011			396.2	0.0132	4.2	8.8	12.2	
35.2005	374.1	0.0010			300.6	0.0187	3.6	8.7	13.2	
35.3005	245.9	0.0008			213.0	0.0103	3.03	9.1		
40.2005	427.4	0.00065			344.0	0.0148	6.0	13.1	18.5	
40.3005	252.9	0.0008			250.0	0.0145	6.5	14.1	20.0	
40.6005	43.7	0.004			40.2	0.0153	3.4	7.8	11.7	15.2
45.2005	518.9	0.001			425.8	0.0206	8.1	17.2	23.9	
45.5001	129.7	0.0013	107.16	0.0155	106.2	0.0224	7.3	17.7	25.3	31.3
45.5002	134.4	0.0015			114.4	0.0191	9.3	18.2	25.0	30.9
45.5003	133.1	0.0033			129.6	0.0201	7.9	16.6	23.7	29.4
45.5005	111.8	0.00286			100.6	0.019	9.5	17.5	23.8	29.3
45.5501	96.0	0.0013	80.99	0.0118	78.4	0.0232	6.7	16.2	23.7	29.3
45.5502	99.0	0.0024			68.2	0.0266	7.8	15.5	22.1	27.9
45.5503	90.6	0.0021			77.7	0.0178	7.0	15.8	23.0	29.1
45.5505	101.9	0.0023			71.5	0.0162	10.0	18.1	24.8	30.2
50.2005	637.5	0.0008			532.8	0.0359	12.0	24.2	33.0	
50.3005	460.6	0.0008			373.3	0.0357	13.5	26.9	36.0	
50.4005	268.8	0.0006			243.1	0.0353	13.4	25.7	34.3	
55.4001	400.6	0.00116			362.5	0.0734	26.2	41.8	52.5	59.9
55.4005	437.9	0.00158	404.9	0.0243	362.5	0.0395	24.8	42.2	52.5	59.7
55.0160	102.1	0.002			88.0	0.0165	11.2	17.6	22.6	
55.0560	114.9	0.0021			92.8	0.0244	9.8	18.0	24.4	30.1
55.1060	98.4	0.0019			78.0	0.0254	10.1	18.4	24.4	29.5
45.55*	81.3	0.0014			79.4	0.0185	4.8	12.4	18.9	24.1
55.60**	99.8	0.0011			84.6	0.0188	6.9	13.4	18.4	22.8

* 45 wt. % $\text{Ba}_{0.45}\text{Sr}_{0.55}\text{TiO}_3$ and 55 wt. % Mg_2SiO_4

** 40 wt. % $\text{Ba}_{0.55}\text{Sr}_{0.45}\text{TiO}_3$ and 60 wt. % MgO

The compositional designations for the materials listed in Tables 1-5 mean the weight percentage of three different phases. For example, the designation 35.1005

BSTO/Mg₂SiO₄/MgO means that the sample contains 5 wt. % MgO and 95 wt. % BSTO/Mg₂SiO₄. In the 35.1005 sample, Mg₂SiO₄ comprises 10 wt. % of the total of the BSTO/Mg₂SiO₄, and the barium strontium titanate comprises 90 wt.% of the BSTO/Mg₂SiO₄. The barium strontium titanate phase of the 35.1005 sample has the formula Ba_{0.35}Sr_{0.65}TiO₃.

In addition to the ternary BSTO/Mg₂SiO₄/MgO compositions, Table 1 includes two binary BSTO/Mg₂SiO₄ (Sample No. 45.55) and BSTO/MgO (Sample No. 55.60) compositions for comparison purposes. The ternary compositions exhibit favorable properties in comparison with the binary compositions.

Table 2

Low and High Frequency Data of BSTO with varying
Amounts of CaTiO₃ and Mg₂SiO₄

BSTO/ CaTiO ₃ / Mg ₂ SiO ₄	Dielectric Constant (1MHz)	Dielectric Loss (1MHz)	Dielectric Constant (10GHz)	Dielectric Loss (10GHz)	Dielectric Constant (24GHz)	Dielectric Loss (24GHz)	Tunability (2V/um) (%)	Tunability (4V/um) (%)	Tunability (6V/um) (%)	Tunability (8V/um) (%)
45.1010	802.0	0.0008	800.4	0.0050	591.5	0.0231	5.0	14.5	2.04	32.8
45.1020	579.3	0.0009			462.2	0.0244	4.8	14.8	25.0	33.6
45.1030	395.6	0.0009	411.3	0.0134	333.2	0.0240	5.2	15.3	25.0	33.1
45.1040	249.4	0.0005	261.1	0.0092	213.1	0.0245	5.6	15.8	25.2	32.8
45.1050	163.5	0.0006	162.1		137.9	0.0230	4.5	15.1	23.8	31.0
45.1060	85.3	0.0001	87.2	0.0064	73.51	0.0181	3.8	11.8	18.1	24.0
45.2020	449.7	0.0021	408.7	0.0632			8.9	16.4	37.0	43.8
45.2030	319.8	0.0018	377.4	0.0613			6.7	22.8	33.8	41.0
45.2040	225.5	0.0027	165.0	0.0517	146.6	0.068	7.2	20.6	30.1	
50.1040	317.9	0.0008	356.5	0.017	269.1	0.0334	9.5	24.3	35.7	43.9
50.2040	242.9	0.0031	177.6	0.0640	154.0	0.082	7.2	22.5	33.2	42.0
55.1020	896.9	0.001	853.8	0.043	643.3	0.0495	15.2	33.9	46.2	55.0
55.1040	396.0	0.0011	401.6	0.028	316.1	0.054	15.2	33.8	45.8	53.6
55.2010	872.6	0.0024			548.1	0.259	15.9	38.5	51.1	
55.2020	596.6	0.0032			430.2	0.133	19.4	41.3	52.6	59.4
55.2040	266.0	0.0023			197.3	0.1029	6.5	25.4	37.6	45.6
55.2050	133.5	0.0029	108.3	0.0561	98.9	0.068	4.3	17.8	27.4	
55.2060	65.85	0.0015	53.1	0.0362	63.5	0.106	2.2	9.0	15.6	
55.2070	29.2	0.0005	25.9	0.0190	13.8	0.157	0.3	2.4	4.8	

Table 3

Low and High Frequency Data of BSTO with varying
Amounts of MgZrSrTiO₆ and MgO

BSTO/MgZrSrTiO ₆ /MgO	Dielectric Constant (1MHz)	Dielectric Loss (1MHz)	Tunability (2V/um) (%)	Dielectric Constant (100MHz)	Dielectric Loss (100MHz)	Dielectric Constant (10GHz)	Dielectric Loss (10GHz)
55.3030	286.0	0.00066	19.1	223	0.00168	311.2	0.035
55.3050	80.6	0.00044	6.5			74.2	0.0106
55.3060	49.9	0.00099	3.4			47.1	0.0081

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Table 4

Low and High Frequency Data of BSTO with varying
Amounts of MgTiO₃ and MgO

BSTO/MgTiO ₃ /MgO	Dielectric Constant (1MHz)	Dielectric Loss (1MHz)	Tunability (2V/um) (%)	Dielectric Constant (100MHz)	Dielectric Loss (100MHz)	Dielectric Constant (10GHz)	Dielectric Loss (10GHz)
55.3020	460.0	0.00068	22.0	372.0	0.00186	364.0	0.022
55.3030	265.0	0.00084	14.9			283.8	0.0275
55.3050	72.8	0.00046	5.5			68.3	0.013
55.3060	43.8	0.00088	2.4			45.1	0.0077

Table 5

Low and High Frequency Data of BSTO with varying
Amounts of MgAl₂O₄ and MgO

BSTO/MgO/MgAl ₂ O ₄	Dielectric Constant (1MHz)	Dielectric Loss (1MHz)	Tunability (2V/um) (%)	Tunability (8V/um) (%)	Dielectric Constant (10GHz)	Dielectric Loss (10GHz)
55.2020	336.4	0.00097	8.1			
55.3030	108.2	0.00089	8.0		97.6	0.0201
55.2535	97.2	0.00086	6.3	27.9		
55.0560	106.2	0.00061	4.7			
55.1060	90.1	0.00057	4.8		96.4	0.0177
55.2060	64.2	0.0006	4.6			
55.3060	53.0	0.00062	4.4			
55.6001	155.0	0.006	34.3			
55.6020	69.5	0.0015	11.0		57.3	0.029
55.6025	47.3	0.00098	6.2	20.4		
55.6030	41.5	0.001	3.9			
60.2515	439.0	0.0018	18.0			
60.0160	185.1	0.0026	17.8	50.7		

As shown in Tables 1-5, the dielectric constant can be tailored by changing the percentage of one phase while maintaining the tunability and dielectric loss. An example of this is shown in Table 1, where changing the percentage of the Mg₂SiO₄ phase in the

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BSTO/Mg₂SiO₄/MgO ternary material changed the 24 GHz dielectric constant of samples 50.2005, 50.3005 and 50.4005 from 532.8 to 373.3 to 243.1, respectively. The tunability and 24 GHz loss tangent of 50.2005, 50.3005 and 50.4005 remain the same. For different RF applications, certain dielectric constants may be desired. The ternary composites make it possible to engineer the material with the desired dielectric constant without changing the dielectric loss and tunability.

Another significant improvement shown in Tables 1-5 is that the materials can also be designed to keep the dielectric constant and tunability the same while decreasing the dielectric loss, which is not exhibited by binary composites. As an example, in Table 1, the 24 GHz dielectric loss tangent of 55.4001 and 55.4005 has been reduced almost by half by changing the percentage of MgO phase in BSTO/Mg₂SiO₄/MgO composite, but the dielectric constant and tunability remain the same.

The present materials exhibit favorable voltage handling characteristics. The materials preferably withstand very high fields and voltages without structural or ionic breakdowns. An example of this characteristic is shown in Table 6 under an 8V/micron amplified field.

Table 6

Voltage Handling Characteristics over Time of BSTO Ternary Composites

Time (minutes)	30	60	120	180	240	300	360	420	480	600	960
Leakage Current (mA) Ba _{0.55} Sr _{0.45} TiO ₃ + Mg ₂ SiO ₄ + CaTiO ₃	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000
Leakage Current (mA) Ba _{0.55} Sr _{0.45} TiO ₃ + Mg ₂ SiO ₄ +MgO	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000	0.000

The zero leakage current shown in Table 6 is significant in view of the fact that the base material is BSTO. Typically, BSTO is considered a type II dielectric, which exhibits leakage over time and temperature. This causes reduced reliability in the part. With the additions of the multiple metal oxides to the base BSTO phase, the reliability of the dielectric increases.

In accordance with an embodiment of the invention, the present materials may be provided in the form of a uniaxially pressed bulk part. Alternatively, large bulk parts of

the present materials may be made by isostatic pressing. To press a uniaxial part, the powders may include a conventional binder to help hold the part together. For example, the pressed material may contain a basic acrylic binder in an amount of 2 percent by weight. The powder may be measured, placed in a metal die, and pressed to a pressure between 5,000 and 10,000 psi. In the case of isostatic pressing, the powder may be packed into a molded rubber container. The container is sealed with only a small tube opening. This tube is then attached to a vacuum pump and the air is pumped out of the bag. After the vacuum sealing process is done, the tube is clamped and the bag is placed in a container in an isostatic press. The isostatic press typically uses hydraulic pressure to apply from 30,000 to 60,000 psi of pressure to the part. The green ceramic density may be, for example, approximately 60 percent of theoretical.

In accordance with another embodiment, tape casting techniques may be used to make various types of components comprising the present materials. Tape cast parts may be made by adding a conventional dispersant and solvent system to a jar mill with the powders and liquid mixing media and mixing balls. Dispersion is performed typically from 18 to 24 hours. After the dispersion process, conventional plasticizers and binders are preferably added and the total mixture is mixing for several hours. The resultant tape slurry may then be de-aired by vacuum. At this point, the slurry may be injected into a tape caster and cast. The tape is then dried, cut and sintered. The sintering process typically includes a binder burn out stage and a sintering stage.

Another processing technique is to screen print a film of the present material. For example, powder forms of BaTiO_3 and SrTiO_3 may be mixed to form the desired stoichiometry. The powders may be ball-milled in either a liquid solvent, de-ionized water or dry mixed with ceramic grinding media for several hours. These powders are then allowed to dry. The mixed powder may then be calcined to form BSTO. The calcined powder then undergoes another mixing step with the additional metal oxide phase powders in the desired ratios to form the ceramic composite. This mixing may be performed in either a liquid medium or dry. The composite powder is then dried and ground to a workable particle size. At this point, the powder may be mixed in the desired ratio with a screen print binder system which preferably contains a combination of medium and solvent. The ratio of ceramic filler in many cases may be based on a 70 to 75 percent solids loading by weight. The resultant ink may be mixed on a 3-roll mill. However, other mixing methods may be suitable. A typical amount of time for mixing is about 30 minutes. During the mixing process, the powder may

be allowed to flow through the mill to allow for uniform mixing. A viscosity test is preferably performed after the ink is made. The viscosities of the inks usually range from 35,000 to 65,000 cps, depending on the screens and the types of patterns which will be printed. Other tests such as rheology tests may be performed as needed depending on the application.

In one embodiment, once the present materials are printed or formed, microwave structures can be placed on top of the films. For example, a varactor may be made by printing a thick film ink of the tunable dielectric onto a substrate by a screen printing process. The dielectric ink may be forced through a wire screen in a pattern that is determined by the screen. The dielectric pattern is then sintered. The substrate then undergoes a conventional lift-off photolithography process and E-beam gold deposition process. The photoresist is then stripped and the patterned gold remains on the substrate. Hundreds of varactors may be made on the substrate. Each of the varactors may be singulated by a dicing saw and each of the varactors can be tested by known techniques.

Other types of thick film structures include vertical capacitors where a metallic layer is printed and fired, then the ceramic is fired on top. The process for making this type of device may be similar to that described for the varactors. The difference is that a film of, e.g., platinum may be placed on the substrate prior to the thick film in order to form a bottom electrode. A subsequent step would be to place a pattern on top of the ceramic substrate. Thin films of these material can also be produced.

The present materials are particularly unique and ideal for microwave component designs because its tuning characteristics allow for the device to have properties that vary. The variation allows for new concepts in design for filters which can vary the frequency of operation, for antennas to scan and track satellites electronically, and it allows for frequency hopping of microwave devices as well as many other applications. This unique property can be used to build tunable devices for RF, microwave, and mill-wave applications. These tunable devices include varactors (variable capacitors), tunable filters, phase shifters, tunable delay lines, VCO (voltage controlled oscillators), tunable dielectric resonators, tunable impedance-matching devices, and the like.

In accordance with an embodiment of the invention, the present materials may be incorporated in phased array antennas which are compact, light and relatively inexpensive to make and operate. The tunable dielectric materials can be used as replacements for the more expensive and high power driven ferrites currently used in large scale phased arrays.

The present materials are also much more compact, and may be cheaper than materials used in mechanically scanning antennas. The present materials also have the advantage of lower loss without amplification than semiconductor tunable devices at microwave frequencies.

One of the applications of the present materials is to build high performance and low cost dielectric phase shifters. The phase of the dielectric phase shifters can be controlled by changing dielectric constant through biasing the tunable materials. The dielectric phase shifters can be in many configurations such as planar structures (microstrip line, coplanar), and 3-D structures (rectangle waveguide, finline) to meet different application requirements. The dielectric phase shifters have wide operation frequency range, low insertion loss, low consumption power, low intermodulation distortion and low cost, compared to common used ferrite and semiconductor-based phase shifters. Since phase shifters are a key device in a phased array antenna in both performance and cost of the whole antenna, the performance and cost of the antenna may be significantly improved by using the dielectric phase shifters instead of ferrite and semiconductor phase shifters.

Another application field of the present tunable materials is tunable filters. A tunable filter consists of one or more resonators. Each resonator has a inductor-capacitor (LC) resonating circuit. A filter can be tuned by changing inductance and/or capacitance of the resonator. Since the capacitance of the resonator can be easily changed by using the multi-phase tunable materials of the present invention, a low cost, high performance and compact tunable filter is achievable.

The dielectric tunable filters can find many applications in communication systems. Most current communication system use fixed filters. However, future communications require wideband communications using frequency-hopping techniques, so that large amounts of digital data can be transferred over the band. A critical component for these applications is a low cost fast-acting tunable filter. Current tunable filters cannot meet the requirements in both performance and cost. Digital data could be distributed or encoded over a band of frequencies in a sequence determined by controlling circuitry of the tunable filter. This would allow for several users to transmit and receive over a common range of frequencies.

The materials of the present invention provide increased tuning characteristics, very stable structure with applied voltage, good loss characteristics, good temperature stability, and adjustable dielectric constant with desired tuning and loss. The present materials enable many new applications in broadband wireless communications that are

currently not possible. In addition, the materials allow for components and antennas to be built at a low cost so that traditionally expensive products can be affordable to individuals, such as phased array antennas and tunable filters.

5 Whereas particular embodiments of this invention have been described above for purposes of illustration, it will be evident to those skilled in the art that numerous variations of the details of the present invention may be made without departing from the invention as defined in the appended claims.

WHAT IS CLAIMED IS:

1. An electronically tunable dielectric material comprising at least one electronically tunable dielectric phase and a total of from about 1 to about 80 weight percent of at least two additional metal oxide phases.
2. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise a total of from about 3 to about 65 weight percent of the material.
3. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise a total of from about 5 to about 60 weight percent of the material.
4. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise a total of from about 10 to about 50 weight percent of the material.
5. The electronically tunable dielectric material of Claim 1, wherein the dielectric material consists essentially of two of the additional metal oxide phases.
6. The electronically tunable dielectric material of Claim 5, wherein the two additional metal oxide phases have a weight ratio of from about 1:100 to about 100:1.
7. The electronically tunable dielectric material of Claim 5, wherein the two additional metal oxide phases have a weight ratio of from about 1:10 to about 10:1.
8. The electronically tunable dielectric material of Claim 5, wherein the two additional metal oxide phases have a weight ratio of from about 1:5 to about 5:1.
9. The electronically tunable dielectric material of Claim 1, wherein the at least one electronically tunable dielectric phase is selected from barium strontium titanate, barium titanate, strontium titanate, barium calcium titanate, barium calcium zirconium titanate, lead titanate, lead zirconium titanate, lead lanthanum zirconium titanate, lead niobate, lead tantalate, potassium strontium niobate, sodium barium niobate/potassium phosphate, potassium niobate, lithium niobate, lithium tantalate, lanthanum tantalate, barium calcium zirconium titanate, sodium nitrate, and combinations thereof.
10. The electronically tunable dielectric material of Claim 1, wherein the at least one electronically tunable dielectric phase comprises barium strontium titanate.

11. The electronically tunable dielectric material of Claim 10, wherein the barium strontium titanate is of the formula $\text{Ba}_x\text{Sr}_{1-x}\text{TiO}_3$, where x is from about 0.15 to about 0.6.

12. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise oxides of at least two metals selected from Be, Mg, Ca, Sr, Ba, Ra, Li, Na, K, Rb, Cs, Al, Zr, Zn, Fr, B, Fe, Mn, Cu, Cr, Ti, Ta, Nb, Mo, W, Ni, Pd, Pb, Bi, Si, Sn, Hf and rare earths.

13. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise oxides of at least two metals selected from Mg, Si, Ca, Zr, Ti and Al.

14. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise at least two Mg-containing compounds.

15. The electronically tunable dielectric material of Claim 14, further comprising at least one Mg-free compound.

16. The electronically tunable dielectric material of Claim 15, wherein the Mg-free compound comprises an oxide of a metal selected from Si, Ca, Zr, Ti and Al.

17. The electronically tunable dielectric material of Claim 15, wherein the Mg-free compound comprises a rare earth oxide.

18. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise a Mg-containing compound and a Mg-free compound.

19. The electronically tunable dielectric material of Claim 18, wherein the Mg-free compound comprises an oxide of a metal selected from Ca, Si, Zr, Ti and Al.

20. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise at least one material selected from Mg_2SiO_4 , MgO, CaTiO_3 , MgZrSrTiO_6 , MgTiO_3 , MgAl_2O_4 , WO_3 , SnTiO_4 , ZrTiO_4 , CaSiO_3 , CaSnO_3 , CaWO_4 , CaZrO_3 , MgTa_2O_6 , MgZrO_3 , MnO_2 , PbO, Bi_2O_3 and La_2O_3 .

21. The electronically tunable dielectric material of Claim 1, wherein the additional metal oxide phases comprise at least one material selected from Mg_2SiO_4 , MgO, CaTiO_3 , MgZrSrTiO_6 , MgTiO_3 , MgAl_2O_4 , MgTa_2O_6 and MgZrO_3 .

22. The electronically tunable dielectric material of Claim 1, wherein the material has a tunability of at least 25 percent at 8V/micron.

23. The electronically tunable dielectric material of Claim 1, wherein the material has a tunability of at least 30 percent at 8V/micron.

24. A method of making an electronically tunable dielectric material comprising:

mixing particles of at least one electronically tunable dielectric material and a total of from about 1 to about 80 weight percent of particles of at least two additional metal oxide materials; and

sintering the material.

25. The method of Claim 24, wherein the electronically tunable dielectric particles and the additional metal oxide particles have average particle sizes of from about 0.1 to about 5 micron.

26. The method of Claim 24, wherein the electronically tunable dielectric particles and the additional metal oxide particles have average particle sizes of from about 1.5 to about 2.5 micron.

27. The method of Claim 24, wherein the additional metal oxide phases comprise a total of from about 3 to about 65 weight percent of the material.

28. The method of Claim 24, wherein the additional metal oxide phases comprise a total of from about 5 to about 60 weight percent of the material.

29. The method of Claim 24, wherein the additional metal oxide phases comprise a total of from about 10 to about 50 weight percent of the material.

30. The method of Claim 24, wherein the dielectric material consists essentially of two of the additional metal oxide phases.

31. The method of Claim 30, wherein the two additional metal oxide phases have a weight ratio of from about 1:100 to about 100:1.

32. The method of Claim 30, wherein the two additional metal oxide phases have a weight ratio of from about 1:10 to about 10:1.

33. The method of Claim 30, wherein the two additional metal oxide phases have a weight ratio of from about 1:5 to about 5:1.

34. The method of Claim 24, wherein the at least one electronically tunable dielectric phase is selected from barium strontium titanate, barium titanate, strontium titanate, barium calcium titanate, barium calcium zirconium titanate, lead titanate, lead zirconium titanate, lead lanthanum zirconium titanate, lead niobate, lead tantalate, potassium strontium niobate, sodium barium niobate/potassium phosphate, potassium niobate, lithium

niobate, lithium tantalate, lanthanum tantalate, barium calcium zirconium titanate, sodium nitrate, and combinations thereof.

35. The method of Claim 24, wherein the at least one electronically tunable dielectric phase comprises barium strontium titanate.

36. The method of Claim 35, wherein the barium strontium titanate is of the formula $\text{Ba}_x\text{Sr}_{1-x}\text{TiO}_3$, where x is from about 0.15 to about 0.6.

37. The method of Claim 24, wherein the additional metal oxide phases comprise oxides of at least two metals selected from Be, Mg, Ca, Sr, Ba, Ra, Li, Na, K, Rb, Cs, Al, Zr, Zn, Fr, B, Fe, Mn, Cu, Cr, Ti, Ta, Nb, Mo, W, Ni, Pd, Pb, Bi, Si, Sn, Hf and rare earths.

38. The method of Claim 24, wherein the additional metal oxide phases comprise oxides of at least two metals selected from Mg, Si, Ca, Zr, Ti and Al.

39. The method of Claim 24, wherein the additional metal oxide phases comprise at least two Mg-containing compounds.

40. The method of Claim 39, further comprising at least one Mg-free compound.

41. The method of Claim 40, wherein the Mg-free compound comprises an oxide of a metal selected from Si, Ca, Zr, Ti and Al.

42. The method of Claim 40, wherein the Mg-free compound comprises a rare earth oxide.

43. The method of Claim 24, wherein the additional metal oxide phases comprise a Mg-containing compound and a Mg-free compound.

44. The method of Claim 43, wherein the Mg-free compound comprises an oxide of a metal selected from Si, Ca, Zr, Ti and Al.

45. The method of Claim 24, wherein the additional metal oxide phases comprise at least one material selected from Mg_2SiO_4 , MgO , CaTiO_3 , MgZrSrTiO_6 , MgTiO_3 , MgAl_2O_4 , WO_3 , SnTiO_4 , ZrTiO_4 , CaSiO_3 , CaSnO_3 , CaWO_4 , CaZrO_3 , MgTa_2O_6 , MgZrO_3 , MnO_2 , PbO , Bi_2O_3 and La_2O_3 .

46. The method of Claim 24, wherein the additional metal oxide phases comprise at least one material selected Mg_2SiO_4 , MgO , CaTiO_3 , MgZrSrTiO_6 , MgTiO_3 , MgAl_2O_4 , MgTa_2O_6 and MgZrO_3 .

47. The method of Claim 24, wherein the material has a tunability of at least 25 percent at 8V/micron.

48. The method of Claim 24, wherein the material has a tunability of at least 30 percent at 8V/micron.

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(54) Title: ELECTRONICALLY TUNABLE, LOW-LOSS CERAMIC MATERIALS INCLUDING A TUNABLE DIELECTRIC PHASE AND MULTIPLE METAL OXIDE PHASES

(57) Abstract: Electronically tunable dielectric materials having favorable properties are disclosed. The electronically tunable materials include an electronically tunable dielectric phase such as barium strontium titanate in combination with at least two additional metal oxide phases. The additional metal oxide phases may include, for example, oxides of Mg, Si, Ca, Zr, Ti and Al. The electronically tunable materials may be provided in bulk, thin film and thick film forms for use in devices such as phased array antennas, tunable filters and the like. The materials are useful in many applications, including the area of radio frequency engineering and design.



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INTERNATIONAL SEARCH REPORT

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According to International Patent Classification (IPC) or to both national classification and IPC		
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Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched		
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C. DOCUMENTS CONSIDERED TO BE RELEVANT		
Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X,P	WO 01 99224 A (PARATEK MICROWAVE, INC.) 27 December 2001 (2001-12-27) abstract page 10	1,24
X	WO 00 28613 A (PARATEK MICROWAVE, INC.) 18 May 2000 (2000-05-18) page 4, line 22 - line 26	1,24
X	US 6 074 971 A (L.H. CHIU ET AL.) 13 June 2000 (2000-06-13) cited in the application abstract	1,24
X	L. ZHOU ET AL.: J. AM. CERAM. SOC., vol. 74, no. 11, - 1991 pages 2925-2927, XP002180647 abstract	1,24
-/--		
<input checked="" type="checkbox"/> Further documents are listed in the continuation of box C. <input checked="" type="checkbox"/> Patent family members are listed in annex.		
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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT		
Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	EP 0 615 262 A (TDK CORP.) 14 September 1994 (1994-09-14) claims 1-3 -----	1,24
X	GB 761 307 A (ERIE RESISTOR CORP.) 14 November 1956 (1956-11-14) claims 1-5 -----	1,24

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

PCT/US 02/01856

Patent document cited in search report		Publication date	Patent family member(s)	Publication date
WO 0199224	A	27-12-2001	AU 6842801 A WO 0199224 A1 US 2002034667 A1	02-01-2002 27-12-2001 21-03-2002
WO 0028613	A	18-05-2000	AU 1342800 A CN 1325552 T EP 1135825 A1 WO 0028613 A1	29-05-2000 05-12-2001 26-09-2001 18-05-2000
US 6074971	A	13-06-2000	NONE	
EP 615262	A	14-09-1994	JP 2764513 B2 JP 6215979 A CA 2113060 A1 CN 1092198 A , B DE 69400932 D1 DE 69400932 T2 EP 0615262 A2 KR 190244 B1 US 5403797 A	11-06-1998 05-08-1994 22-07-1994 14-09-1994 02-01-1997 13-03-1997 14-09-1994 01-06-1999 04-04-1995
GB 761307	A	14-11-1956	NONE	

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